

Preliminary Amendment dated: 23 December 2004

Title: An Ion Implantation Device and a Method of Semiconductor Manufacturing ...

Applicants: Horsky et al.

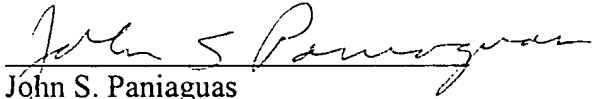
Attorney Docket No.: 211843-00032

REMARKS

It is respectfully requested that the instant Preliminary Amendment be entered prior to examination.

Respectfully submitted,

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